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Micromachines Research and Development in North America

Guest Editors:

Dr. Sima Noghianian

CommScope Ruckus Networks,
350 W Java Dr, Sunnyvale, CA
94089, USA

Dr. Negar Ebadi

Stevens Institute of Technology,
Hoboken, NJ 07030, USA

Dr. George Shaker

Department of Electrical and
Computer Engineering, University
of Waterloo, Waterloo, ON,
Canada

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Message from the Guest Editors

Dear Colleagues,

The objective of this Special Issue is to showcase the latest advances in micromachines and devices in the US and Canada, with the aim of highlighting cutting-edge research and exploring emerging trends in the field. The Special Issue welcomes reviews, original research articles, and communications in the field of micromachines, ultimately providing investigators from the US and Canada with an opportunity to present their exciting, novel research results.

The contributions to this Special Issue will highlight the current frontiers in the fields of micro-/nano-sciences, devices, and applications.

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Dr. George Shaker

Guest Editors



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Special Issue



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Editor-in-Chief

Prof. Dr. Ai-Qun Liu

1. Department of Electrical and Electronic Engineering, The Hong Kong Polytechnic University, Hong Kong, China
2. School of Electrical and Electronic Engineering, Nanyang Technological University, Singapore 639798, Singapore

Message from the Editor-in-Chief

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Micromachines Editorial Office
MDPI, Grosspeteranlage 5
4052 Basel, Switzerland

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